Docket: 740756-2434

	IN THE UNITED STATES PATENT AN	D TRA	DEMARK OFFICE	010	
			#4/105	050	
In re l	New Patent Application of)	And	0.14	
Shunp	oei YAMAZAKI et al.)	Splot		
Japanese Priority Application No. 2001-040848) Attı	n: Applications	11	
Japanese Priority Date: February 16, 2001)	Branch		
For:	METHOD OF MANUFACTURING A)			
	SEMICONDUCTOR DEVICE) Dat	e: February 14, 2002		

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents and Trademarks Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

U.S. Patent No. 5,643,826 is listed in the patent family of Japanese Patent Laid-Open No. 07-183540.

Respectfully submitted,

Eric J. Robinson

Registration No. 38,285

NIXON PEABODY LLP 8180 Greensboro Drive, Suite 800 McLean, Virginia 22102 (703) 790-9110 U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known Substitute for form 1449A/PTO **Application Number** INFORMATION DISCLOSURE February 12, 2002 Filing Date STATEMENT BY APPLICANT Shunpei YAMAZAKI First Named Inventor (use as many sheets as necessary) Group Art Unit **Examiner Name** Sheet of Attorney Docket Number 740756-2434 **U.S. PATENT DOCUMENTS** U.S. Patent Document Date of Publication of Cited Pages, Columns, Lines, Where Relevant Cite Examiner Document MM-DD-YYYY Passages or Relevant Figures Appear Initials Name of Patentee or Applicant of Cited Document Number Kind Code² 5,643,826 Ohtani et al. 07/01/1997 5,932,893 Miyanaga et al. 08/03/1999 5,789,284 08/04/1998 Yamazaki et al. 6,071,766 06/06/2000 Yamazaki et al. 5,700,333 Yamazaki et al. 12/23/1997 5,961,743 Yamazaki et al. 10/05/1999 FOREIGN PATENT DOCUMENTS Pages, Columns, Lines, Examiner Initials Foreign Patent Document Date of Publication of Cited Name of Patentee or Document MM-DD-YYYY Where Relevant Passages or Applicant of Cited Document Kind Code Relevant Figures Appear T6 Office3 Number⁴ (if known) Japan 07-183540 07/21/1995 Abstract OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the Examiner Cite T^2 Initials' No.1 item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published. Examiner Date

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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.